

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: Yeo, *et al.*

Docket No.: TSM03-0760

Serial No.: 10/803,712

Art Unit: 1795

Filed: March 18, 2004

Examiner: Raymond, Brittany L.

For: Immersion Fluid for Immersion Lithography, and Method of Performing
Immersion Lithography

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

AMENDMENT

Dear Sir:

The following amendments and remarks are presented in response to the Examiner's Office Action mailed October 28, 2008. Please amend the above-referenced application as follows.